



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#71113  
7/28/02

In re application of : Confirmation No. 4252  
Yoichi MORI et al. : Docket No. 2000-1578A  
Serial No. 09/714,220 : Group Art Unit 1754  
Filed November 17, 2000 : Examiner Ngoc-Yen M. Nguyen

METHOD AND APPARATUS FOR  
TREATING A WASTE GAS CONTAINING  
FLUORINE-CONTAINING COMPOUNDS

RECEIVED  
JUL 18 2002  
TC 1700

ELECTION OF INVENTION

Assistant Commissioner for Patents,  
Washington, D.C.

Sir:

In response to the restriction requirement of June 19, 2002, Applicants in the above-referenced U.S. patent application hereby elect the invention of Group II corresponding to claims 5-8. An early and favorable action on the merits is respectfully requested.

Respectfully submitted,

Yoichi MORI et al.

By: \_\_\_\_\_

Nils E. Pedersen  
Registration No. 33,145  
Attorney for Applicants

NEP/krl  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
July 17, 2002

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975